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Thin Solid Films 252 (1994) 153

Thin Solid Films

Author Index of Volume 252

Al-Shareef, H. N., 38
Asada, H., 49
Atanassova, E., 89
Auciello, O., 38

Balasubramanian, C., 67
Barnes, G. T., 44
Bauer-Grosse, E., 82
Bellur, K. R., 38
Beshkov, G., 89
Bhattacharya, E., 78
Buffeteau, T., 111

Carlsson, J.-O., 19
Chen, X., 38
Chinn, D., 145
Chiu, H.-T., 13

Desbat, B., 111
Dimitrova, T., 89
Dubrovsky, T., 1
de la Cruz, W., 61

Ehrhardt, J. J., 105

Fargues, D., 105

Gally, A., 105
Ghanashyam Krishna, M., 7
Giasson, S., 111
Gopalakrishnan, R., 54
Gordillo, G., 61
Goujard, S., 120
Grandjean, B. P. A., 26
Gunasekhar, K. R., 7

Harley, E. R., 4
Hsu, J.-S., 13
Huang, C., 139

Janata, J., 145
Jansen, F., 32
Johansson, A.-S., 19

Kaliaguine, S., 26
Karmalkar, S., 78
Katz, H. E., 4
Kawano, H., 49
Kingon, A. I., 38
Kitada, M., 135
Krommenhoek, S., 32
Kumar, S. S., 78

Lambooy, P., 75
Li, T., 139
Lu, J., 19

Mangalaraj, D., 67
Marks, M. R., 54
Meena, P., 67
Mohan, S., 7
Moreno, L. C., 61

Narayandass, SA. K., 67
Narvaez, P., 4
Nevernov, I., 1
Nevernova, I., 1
Nicolini, C., 1

Palermo, T., 111
Pazov, J., 89
Peng, J. B., 44

Richmond, E. D., 98
Russell, T. P., 75

Salem, J. R., 75
Shu, J., 26
Srinivasulu, S., 7
Suresh, T. B., 78
Swarnalatha, M., 7

Tawil, H., 120
Teheran, P., 61
Thompson, J. A., 54
Trindade, B., 82
Turlet, J. M., 111

Udaka, M.,

Vandenbulcke, L., 120
Vieira, M. T., 82

Wang, K., 139
Wu, N., 139

Xia, X., 139
Xu, G., 139
Xu, L., 139

Yamamoto, K., 135
Yang, A. C.-M., 131

Zhao, X., 139

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ELSEVIER

Thin Solid Films 252 (1994) 155–157

Thin Solid Films

Subject Index of Volume 252

Adhesion
measurement of equi-biaxial stress in adhered polyimide films by tilted beam polarized light microscopy, 131
Adsorption
study of boundary film formation with overbased calcium sulfonate by PM-IRRAS spectroscopy, 111
Amorphous materials
electroless plated nickel contacts to hydrogenated amorphous silicon, 78
Anisotropy
study of boundary film formation with overbased calcium sulfonate by PM-IRRAS spectroscopy, 111
Annealing
effect of thickness on interdiffusion between niobium/permalloy bilayer thin films, 135
Atomic force microscopy
two-dimensional hexatic-B phase of single Langmuir–Blodgett monolayers observed by atomic force microscopy, 44
Auger electron spectroscopy
growth and oxidation of thin cerium films on polycrystalline platinum, 105

Boron carbide
oxidation behaviour of 2D and 3D carbon/carbon thermostructural materials protected by CVD polylayer coatings, 120

Capacitors
dielectric, conduction and breakdown studies on europium fluoride thin films, 67
Carbides
structural stability and crystallization studies of metastable sputtered W–Ni–C films, 82
Cerium
growth and oxidation of thin cerium films on polycrystalline platinum, 105
Chemical vapour deposition
low pressure chemical vapor deposition of silicon carbide thin films from hexamethyldisilane, 13
TEM investigation of CVD graphite on nickel, 19
Coatings
morphological study of hydrogen permeable Pd membranes, 26
oxidation behaviour of 2D and 3D carbon/carbon thermostructural materials protected by CVD polylayer coatings, 120
structural stability and crystallization studies of metastable sputtered W–Ni–C films, 82
Conductivity
dielectric, conduction and breakdown studies on europium fluoride thin films, 67
Contacts
electroless plated nickel contacts to hydrogenated amorphous silicon, 78

Crystallization
morphological study of hydrogen permeable Pd membranes, 26
structural stability and crystallization studies of metastable sputtered W–Ni–C films, 82

Deposition
ultrathin electrically insulating films: synthesis, layer deposition and dielectric properties of 1,1,10,10-tetrahydroperfluorodecane-1,10 diol diphosphate, 4
Deposition process
preparation and characterization of SnO_2 thin films deposited by spray pyrolysis from $SnCl_2$ and $SnCl_4$ precursors, 61
Dielectric properties
dielectric, conduction and breakdown studies on europium fluoride thin films, 67
effect of composition and annealing conditions on the electrical properties of $Pb(Zr_xTi_{1-x})O_3$ thin films deposited by the sol–gel process, 38
thin thermal SiO_2 after NH_3 or N_2O plasma action under plasma-enhanced chemical vapour deposition conditions, 89
ultrathin electrically insulating films: synthesis, layer deposition and dielectric properties of 1,1,10,10-tetrahydroperfluorodecane-1,10 diol diphosphate, 4
Dielectrics
effect of composition and annealing conditions on the electrical properties of $Pb(Zr_xTi_{1-x})O_3$ thin films deposited by the sol–gel process, 38
Diffusion
effect of thickness on interdiffusion between niobium/permalloy bilayer thin films, 135

Electrical properties and measurements
preparation and characterization of SnO_2 thin films deposited by spray pyrolysis from $SnCl_2$ and $SnCl_4$ precursors, 61
thin thermal SiO_2 after NH_3 or N_2O plasma action under plasma-enhanced chemical vapour deposition conditions, 89
ultrathin electrically insulating films: synthesis, layer deposition and dielectric properties of 1,1,10,10-tetrahydroperfluorodecane-1,10 diol diphosphate, 4
Europium fluoride
dielectric, conduction and breakdown studies on europium fluoride thin films, 67
Evaporation
explosive vaporization of crystal water on the temperature-programmed heating of a thin film of hydrated calcium nitrate, 49

Fourier transform infrared spectroscopy
study of boundary film formation with overbased calcium sulfonate by PM-IRRAS spectroscopy, 111

Elsevier Science S.A.

Glow discharge
thin film deposition on inside surfaces by plasma enhanced chemical vapor deposition, 32
Gold
experimental study of die attach polymer bleedout in ceramic packages, 54
Graphite
observation of silanated graphite surface with scanning tunnelling microscopy, 1
TEM investigation of CVD graphite on nickel, 19
Growth mechanism
growth and oxidation of thin cerium films on polycrystalline platinum, 105
X-ray photoelectron spectroscopy analysis of the growth kinetics of Ge on Si(001), 98

Insulators
spin-cast thin films of polyaniline, 145
Interfaces
spin-cast thin films of polyaniline, 145
X-ray photoelectron spectroscopy analysis of the growth kinetics of Ge on Si(001), 98
Ion bombardment
thin-film deposition on inside surfaces by plasma enhanced chemical vapor deposition, 32

Langmuir–Blodgett films
optical properties of Langmuir–Blodgett film of hemicyanine containing the rare earth complex anion $Dy(BPMPHD)_2^-$, 139
two-dimensional hexatic-B phase of single Langmuir–Blodgett monolayers observed by atomic force microscopy, 44
Lanthanides
optical properties of Langmuir–Blodgett film of hemicyanine containing the rare earth complex anion $Dy(BPMPHD)_2^-$, 139

Magnetic properties and measurements
effect of thickness on interdiffusion between niobium/permalloy bilayer thin films, 135
Multilayers
effect of thickness on interdiffusion between niobium/permalloy bilayer thin films, 135
ultrathin electrically insulating films: synthesis, layer deposition and dielectric properties of 1,1,10,10-tetrahydroperfluorodecane-1,10 diol diphosphate, 4

Nickel
electroless plated nickel contacts to hydrogenated amorphous silicon, 78
TEM investigation of CVD graphite on nickel, 19
Nickel oxide
experimental study of die attach polymer bleedout in ceramic packages, 54
Optical properties
optical properties of Langmuir–Blodgett film of hemicyanine containing the rare earth complex anion $Dy(BPMPHD)_2^-$, 139
preparation and characterization of SnO_2 thin films deposited by spray pyrolysis from $SnCl_2$ and $SnCl_4$ precursors, 61
Organic substances
method to confine thin solid organic films between flat rigid walls, 75
Oxidation
oxidation behaviour of 2D and 3D carbon/carbon thermostructural materials protected by CVD polylayer coatings, 120
Oxides
thin thermal SiO_2 after NH_3 or N_2O plasma action under plasma-enhanced chemical vapour deposition conditions, 89

Palladium
morphological study of hydrogen permeable Pd membranes, 26
Phase transitions
explosive vaporization of crystal water on the temperature-programmed heating of a thin film of hydrated calcium nitrate, 49
Physical vapour deposition
method to confine thin solid organic films between flat rigid walls, 75
Plasma processing and deposition
thin film deposition on inside surfaces by plasma enhanced chemical vapor deposition, 32
Platinum
growth and oxidation of thin cerium films on polycrystalline platinum, 105
Polymers
experimental study of die attach polymer bleedout in ceramic packages, 54
measurements of equi-biaxial stress in adhered polyimide films by tilted beam polarized light microscopy, 131
spin-cast thin films of polyaniline, 145

Scanning electron microscopy
X-ray photoelectron spectroscopy analysis of the growth kinetics of Ge on Si(001), 98
Scanning tunnelling microscopy
observation of silanated graphite surface with scanning tunnelling microscopy, 1
Schottky barrier
electroless plated nickel contacts to hydrogenated amorphous silicon, 78
Second harmonic generation
optical properties of Langmuir–Blodgett film of hemicyanine containing the rare earth complex anion $Dy(BPMPHD)_2^-$, 139
Sensors
spin-cast thin films of polyaniline, 145
Silane
observation of silanated graphite surface with scanning tunnelling microscopy, 1
Silicon
thin thermal SiO_2 after NH_3 or N_2O plasma action under plasma-enhanced chemical vapour deposition conditions, 89
Silicon carbide
low pressure chemical vapor deposition of silicon carbide thin films from hexamethyldisilane, 13
oxidation behaviour of 2D and 3D carbon/carbon thermostructural materials protected by CVD polylayer coatings, 120
Silicon oxide
method to confine thin solid organic films between flat rigid walls, 75
thin film deposition on inside surfaces by plasma enhanced chemical vapor deposition, 32
Sputtering
structural stability and crystallization studies of metastable sputtered W–Ni–C films, 82

Stress
measurements of equi-biaxial stress in adhered polyimide films by tilted beam polarized light microscopy, 131
Structural properties
structure and microstructure of ion-plated titanium films, 7
Surface and interface states
two-dimensional hexatic-B phase of single Langmuir–Blodgett monolayers observed by atomic force microscopy, 44
Surface defects
two-dimensional hexatic-B phase of single Langmuir–Blodgett monolayers observed by atomic force microscopy, 44
Surface energy
experimental study of die attach polymer bleedout in ceramic packages, 54
Surface morphology
morphological study of hydrogen permeable Pd membranes, 26

Thermal desorption
explosive vaporization of crystal water on the temperature-programmed heating of a thin film of hydrated calcium nitrate, 49
Tin oxide
preparation and characterization of SnO_2 thin films deposited by spray pyrolysis from $SnCl_2$ and $SnCl_4$ precursors, 61
Titanium
structure and microstructure of ion-plated titanium films, 7
Transmission electron microscopy
TEM investigation of CVD graphite on nickel, 19
Tribology
study of boundary film formation with overbased calcium sulfonate by PM-IRRAS spectroscopy, 111

Water
explosive vaporization of crystal water on the temperature-programmed heating of a thin film of hydrated calcium nitrate, 49

X-ray photoelectron spectroscopy
X-ray photoelectron spectroscopy analysis of the growth kinetics of Ge on Si(001), 98